



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 28, 2026

IGI Report Number

LG794646889

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

8.31 X 5.52 X 3.77 MM

GRADING RESULTS

Carat Weight

1.50 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

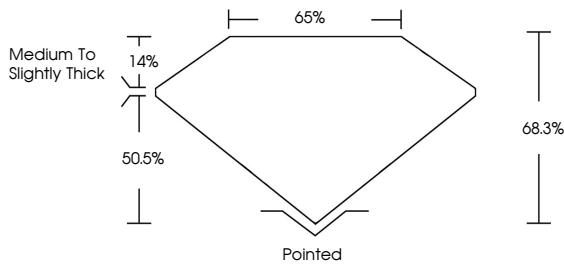
Inscription(s)

 LG794646889

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

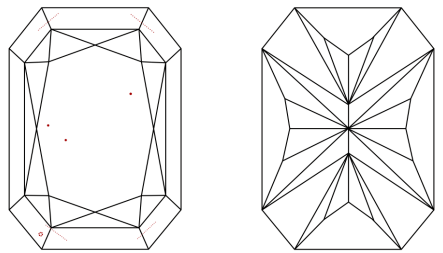
Report verification at igi.org

PROPORTIONS



Medium To Slightly Thick

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

LABORATORY GROWN DIAMOND REPORT

April 28, 2026

IGI Report Number

LG794646889

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

8.31 X 5.52 X 3.77 MM

GRADING RESULTS

Carat Weight

1.50 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG794646889

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI



© IGI 2020, International Gemological Institute

FD - 10 20

April 28, 2026

IGI Report No LG794646889

CUT CORNERED RECT. MODIFIED BRILLIANT

8.31 X 5.52 X 3.77 MM

Carat Weight

1.50 CARAT

Color Grade

E

Clarity Grade

VS 1

Depth

50.5%

Table

14%

Girdle

Medium to Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG794646889

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa